

	Type	Hits	Search Text	DBs
1	BRS	1877	(Trench with MOSFET) and implant\$5	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM TDB
2	BRS	535	S1 and (epitaxial with silicon)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM TDB
3	BRS	2103	trench and (NPN with transistor)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM TDB
4	BRS	10	S3 and S4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM TDB

	Type	Hits	Search Text	DBs
5	BRS	6	"5763902"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM TDB
6	BRS	141	(form with trench) with after with (implant\$5 with layer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM TDB
7	BRS	5	S3 and S7	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM TDB
8	BRS	188	(channel with region) with over with (drift with region)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM TDB

	Type	Hits	Search Text	DBs
<b>9</b>	BRS	45	S4 and trench	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM TDB
<b>10</b>	BRS	229	trench with (NPN with transistor)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM TDB
<b>11</b>	BRS	0	S10 and S11	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM TDB
<b>12</b>	BRS	166	(forming with trench) with after with (forming with implant\$5 with layer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM TDB

	Type	Hits	Search Text	DBs
<b>13</b>	BRS	4161	257/327,330,341.ccls. or 438/270,302,514,519,527,542,548.ccls.	US-PGPUB; USPAT
<b>14</b>	BRS	3344	S13 and implant\$5	US-PGPUB; USPAT
<b>15</b>	BRS	1718	S14 and epitax\$6	US-PGPUB; USPAT
<b>16</b>	BRS	390	S15 and channel and drift	US-PGPUB; USPAT
<b>17</b>	BRS	350	(channel and drift) with implant\$5	US-PGPUB; USPAT
<b>18</b>	BRS	1287	(epitaxial with silicon) with doping	US-PGPUB; USPAT
<b>19</b>	BRS	756	S18 and channel	US-PGPUB; USPAT